503110903 12/20/2014

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2

EPAS ID: PAT3157513

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
YIGUANG JU	12/18/2014
TOMOYA WADA	12/18/2014
NAN YAO	12/18/2014
WENTING SUN	12/18/2014
JINGNING SHAN	12/16/2014

RECEIVING PARTY DATA

Name:	QUANTUMSCAPE CORPORATION
Street Address:	1730 TECHNOLOGY DRIVE
City:	SAN JOSE
State/Country:	CALIFORNIA
Postal Code:	95110

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14569950

CORRESPONDENCE DATA

Fax Number: (408)228-3739

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 510-900-9501

Email: docket@kwanip.com **Correspondent Name: KWAN & OLYNICK LLP**

Address Line 1: 2000 HEARST AVENUE, STE. 305 Address Line 4: BERKELEY, CALIFORNIA 94709

ATTORNEY DOCKET NUMBER:	QS73_QNTMP005US
NAME OF SUBMITTER:	AMBER LUNDY
SIGNATURE:	/Amber Lundy/
DATE SIGNED:	12/20/2014

Total Attachments: 5

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Whereas I, an undersigned inventor, have invented certain new and useful improvements as set forth in the patent application entitled:

PLASMA SYNTHESIS OF METAL AND LITHIUM FLUORIDE NANOSTRUCTURES

(Atty	. Docket No. ((S62_QNTMP005US), (check one)	
	which bea	I have executed a U.S. patent applications U.S. application No U.S. provisional application. (Accompany)	on on even date herewith. (Accompanying) (Not accompanying) sying)
aekno		valuable consideration, the receipt and undersigned inventor, hereby:	sufficiency of which is hereby
title a and p	of business at 1 nd interest in a	nd transfer to QuantumScape Corporati 1730 Technology Drive, San Jose, CA 9 ny and all improvements and inventions upon (including foreign patents and the n.	5110 ("ASSIGNEE"), the entire right, disclosed in, applications based upon,
	Authorize and ing from said a thereof to the	pplication or any division, continuation	to issue any and all United States Patent, substitute, renewal, re-examination or
applic	rm any acts whi cation, as well a	cute all papers and documents and, entired have reasonably necessary in connections any derivative applications thereof, for atents resulting from such applications.	rely at the ASSIGNEE's expense, on with the prosecution of said oreign applications based thereon, and/or
4) the A inven	SSIGNEE, its s	e terms, covenants and conditions of thi uccessors, assigns and other legal repre he inventor's heirs, legal representative	s assignment shall inure to the benefit o sentatives, and shall be binding upon th s and assigns.
5) or une		represent that I have not entered and wit conflicts with this assignment.	ll not enter into any assignment, contrac
	Signed on the	e date indicated beside my signature.	
1)	Signature: Typed Name:	Juyi guong Yiguang Ju	_ Date: 12/18/2014
2)	Signature: Typed Name:	Tomoya Wada	Date:
3)	Signature: Typed Name:	Nan Yao	Date:
4)	Signature: Typed Name:	Wenting Sun	_ Date:
5)	Signature: Typed Name:	Jingning Shan	Date:
QS62	QNTMP005U	S Page 1 of 1	

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(Atty. D	ocket No. Q	S62_QNTMP005US), (check one)			
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S	igned on the	date indicated beside my signature.			
	ignature: yped Name:	Yiguang Ju	Date:		
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	ignature: yped Name:	Nan Yao	Date:		
	ignature: yped Name:	Wenting Sun	Date:	, manufacture	
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1)	Signature: Typed Name:	Viguang Ju		Date:		u.	
2)	Signature: Typed Name:	Tomoya Wada	<u></u>	Date:			
3)	Signature: Typed Name:	Nan Yao		Date:	13-18-	2014	
4)	Signature: Typed Name:	Wenting Sun		Date:		-	
5)	Signature: Typed Name:	Jingning Shan		Date:		_	
QS62	QNTMP005U	S	Page 1 of 1				

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acknov		valuable consideration, the receipt and suffici ndersigned inventor, hereby:	ency of which	is hereby
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	Signed on the	date indicated beside my signature.		
I)	Signature: Typed Name:	Yiguang Ju	Date:	
2)	Signature: Typed Name:	Tomoya Wada	Date:	
3)	Signature: Typed Name:	Nan Yao «	Date:	
4)	Signature: Typed Name:	Wasting Sun	Date: (2)/	8/2014
\$}	Signature: Typed Name:	Jingning Shan	Date:	

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QS62_QNTMP005US

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acknov		valuable consideration, the receipt and sul undersigned inventor, hereby:	ficiency of which is hereby		
title ar	Sell, assign and transfer to QuantumScape Corporation, a Delaware corporation having a ce of business at 1730 Technology Drive, San Jose, CA 95110 ("ASSIGNEE"), the entire right, e and interest in any and all improvements and inventions disclosed in, applications based upon, I patents granted upon (including foreign patents and the right to claim priority), the above-erenced application.				
	Authorize and request the Commissioner of Patents to issue any and all United States Patents ulting from said application or any division, continuation, substitute, renewal, re-examination or sue thereof to the ASSIGNEE.				
applica	Agree to execute all papers and documents and, entirely at the ASSIGNEE's expense, erform any acts which are reasonably necessary in connection with the prosecution of said optication, as well as any derivative applications thereof, foreign applications based thereon, and/or se enforcement of patents resulting from such applications.				
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1)	Signature: Typed Name:	Yigoang Ju	Date:		
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RECORDED: 12/20/2014